



IIT Bombay Nanofabrication Facility

Tool Name: ALD LL (Atomic Layer Deposition Load Lock)

Training and Usage Policy

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Training Policy for ALD LL

Students of Prof. U. Ganguly and Prof. S. Lodha will be trained and allowed to use the ALD LL of their own as all of them are associated with the DST project from which we have got the fund for the system. Rest of the users can take the help of the operators.

Once DST project deliverables are met the system will be made open for training all interested users.

Training Procedure

1. Send a request using the link below:
http://www.cen.iitb.ac.in/equipment_usage/index.php
2. Once approved, go through the system manual to know the system capabilities.
3. Three sessions for observing users handling the system
4. Three supervised hands-on session (sessions to be increased on a case to case basis)
5. Final test taken by the system owner or the operator.

Violation Policy

1. System mishandling would lead to re-authorization by undergoing through the training procedure again.
2. Using non-allowed materials would lead to debarring from using the system for 7days.